

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Meng Tao, et al.
Application No.: 10/822,343
Filing Date: April 12, 2004
Art Unit: 1775
Examiner: Timothy M. Speer
For: SUPPRESSION OF CHEMICAL REACTIVITY ON
SEMICONDUCTOR SURFACES

VIA EFS
Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

**AMENDMENT PURSUANT TO
REQUEST FOR CONTINUED EXAMINATION
(Submission under 37 C.F.R. § 1.114(c))**

Dear Sir:

Applicants submit this Amendment under 37 C.F.R. § 1.114 and filed concurrently with a Request for Continued Examination and respectfully requests entry of this Amendment and consideration of the remarks provided with this paper.

This Amendment is filed in reply to an Office Action made final and mailed on May 14, 2007, that established a three-month shortened statutory time period to respond. Applicants submit that this response is timely filed with a Petition for Extension of Time for one month and the appropriate fees.

In light of the following, Applicants respectfully request entry of this Amendment believed necessary to bring prosecution to a speedy conclusion and to deal justly by Applicants and the public. Applicants believe the Amendment provided herewith defines their invention in

claims that will give them patent protection to which they are justly entitled. This Amendment does not require an additional search on the part of the Examiner. Accordingly, Applicants respectfully request reconsideration and withdrawal of the outstanding rejection and request allowance of claims pending in their Application.

In response to the Office Action and an Advisory Action mailed August 30, 2007, please reconsider the Application for patent as provided in:

Amendments to the Claims provided as a Listing of Claims that begin on page 3; and

Statement of Substance of Interview that begins on page 5; and

Remarks that begin on page 6 of this paper.